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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 1792

Serial No.: 10/528,137

Examiner: MACARTHUR, Sylvia

Filed: December 12, 2005

P.T.O. Confirmation No.: 2307

For.

SUBSTRATE PROCESSING APPARATUS AND METHOD FOR

MANUFACTURING A SEMICONDUCTOR DEVICE

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: June 12, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 14, 2007 for three months, from March 14, 2008 to June 14, 2008.

Please charge the amount of \$1,050.00 to cover the cost of the extension for a large entity to our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

James N. Baker, Reg. No. 40,899

for Mel R. Quintos Attorney for Applicant Reg. No. 31,898

MRQ/JNB/ak

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PATENT & TRADEMARK OFFICE

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